

LOT	QTY	DESCRIPTION
1	1	Advanced Techniques US Inc. Model Pro 1600 Forced Convection Reflow Oven; Asset # 10358; 1. Sealed heating chamber with five (5) time zones allows excellent temperature uniformity across the assembly. 2. Unique design handles various application requirements with a maximum board size of 20" x 20" (508mm x 508mm) per reflow cycle. 3. Built-In Exhaust and Fume Cleaning Unit 4. Built-In Cooldown Cycle 5. Free standing with a small footprint 6. Lead-Free Compatible 7. Nitrogen Ready 8. Stores up to 50 reflow profiles. Profiles may be recalled at the touch of a button and are displayed on the LCD display panel. 9. Safe-Guard Loading/Unloading mechanism 10. PRO 1600 is versatile, flexible, and ensures repeatable results. This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
2	1	150mm ASML Model RVP9507TOX-DB RVP Wet/Dry OX.D.B. Vertical Diffusion Furnace; Asset # 10025; Year of Manufacture 2002; Software: AVP Version 2.6.1 - ABCDEFGHIJKLMNOPQ; L1 (170 Amps), L2 (170 Amps), L3 (170 Amps); 480 V; 60 Hz; 3-Phase; AIC 25000 KA; 145.5 kVA; ASML Self-Contained Power Supply; Exhaust Pressure Monitor (Furnace Cooling, House Exhaust, Scavenger, Gas Cabinet); Gas Detector; Water Flow Meter (Torch Heater); Boat Temp; Data Instruments AD824 Eight Channel Monitor; Schumacher Absolute Bubbler Controller; H-123 (G2 SV2#5 H2 Gas Cabinet); Excellent Condition This item is located at GE - Santa Clara, California
3	1	Blue M Model DCC-206C Parts Bake Oven; For TF Parts; Asset # 10204; 250 Degrees C Maximum Temperature This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
6	LOT	Gastek Gas Sensors; Various Models; Asset # 10370 to # 10384; (Qty-15 Boxes) of Remote Gas Sensors (150+ Sensors) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

7	1	150mm Hypervision Model Chip Unzip Low Stress Backside Preparation System; Asset # 10349; The Hypervision Chip UnZip low stress backside preparation system is particularly useful for the development and analysis of flip-chips, lead-on-chips packaging and advanced chip design with more than three metallization layers, where frontside light emission defect analysis becomes difficult and impossible. This system is a software controlled milling process to remove semiconductor packaging materials such as epoxy molding compound, ceramic, metal and to perform backside thinning on silicon dies of IC devices. The automated process opens a "window" on packaged IC which is flat, mirror-polished with x, y and z precision to 5 um. Leads and wire bonds, when present, are untouched and undamaged, allowing backside photo emission analysis to be carried out on the Hypervision BEAMS V2 system. This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
8	1	150mm Leica Cambridge Model S360 Scanning Electron Microscope; Asset # 10632 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
9	1	150mm Semitool Model SAT1060S0A1PFEU Spray Acid Cleaner/Aqua Regia; Asset # 10059; Year of Manufacture: 1996; With PLC Control; Platinum Strip; Aqua Regia/HCl 37%/Nitric 60-70%; Includes Hot DI Water Heater This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
11	1	150mm Tamar Model CD Measure CD Measurement System; Asset # 10071; Year of Manufacture: 2006; Genmark 4S1005608 (VS#1 / VS#2); Olympus U-LH100-3 Microscope; Olympus UMPlanFL 150X, 100X, 50X, 20X, 5X Objectives; Pulnix Accupixel; Tripp-Lite Isobar Surge Suppressor; Neovo F-417 Flatscreen Monitor; Joystick Controller; Like New Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
12	1	Thermo GasTech Model Safe T Net 2000 Gas Sensors; Asset # 10205; (Qty-24) Gas Sensors; W/ (1) Rittal Cabinet; Gas Detected: (1) SiH4/SiH4 (1) SiH4/B2H6 (2) B2H6/B2H6 (2) NH3/NH3 (1) PH3/H2 (2) NF3/NF3 (1) BLANK/AsH3 (1) B2H6/HCl (1) PH3SiH4/NH3 (2) SiH2Cl2HCl/SiH2Cl2HCl (1) HCl/HCl (1) SiH2CL2HCl/HCl (1) HCl/SiH2Cl2 (11) H2/H2 (2) PH3/PH3 (1) SiH2Cl2/PH3 (1) TEOS/TEOS (1) TEOS/H2 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

13	69	Thermo GasTech Model Safe T Net 2000 Gas Sensors; Asset # 10369; (Qty-69) Gas Monitor Controller Cards. W/ (1) Rittal Cabinet This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
14	1	Vacuum Barrier Corp. Stainless Steel Liquid Nitrogen Vessel; Asset # 10631; with Controller This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
16	1	150mm Branson/IPC Model S2100 Barrel Asher; Asset # 10060; Branson Model 2000C Controller; Branson Model PM112 RF Generator; Chamber Cylinder Size: Diameter 12", Length 19"; Chamber Size: Width 20", Depth 31", Height 18"; Number of Gas Inputs: 3; Good Condition. Item Located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
17	1	Delatech Model SD500-2 EPI Fume Scrubber; Asset # 10626 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
18	1	Ecosys Model ES-100G9-CA4 EPI Fume Scrubber; Asset # 10623 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
19	1	Espec-Tabai Model TSB-5 Thermal Shock Chamber; Asset # 10352; System Mech. X-Y Transfer; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
20	1	150mm Irvine Optical Ultrastation 3B Model 2 Wet Etch Inspection Station; Asset # 10037; US-150 Base; Remote Keypad; Olympus BH2-UMA Microscope; Olympus WHK 10X/20L Optics; Olympus NeoSPlan IC 50X, 20X, 10X, 5X Objectives; (Sample Picture) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
21	1	150mm Irvine Optical Ultrastation 3B Model 2 Wet Etch Inspection Station; Asset # 10038; Remote Keypad; Olympus BH2-UMA Microscope; Olympus WK 10X/20L Optics; Olympus NeoSPlan IC 50X, 20X, 10X, 5X Objectives; (Sample Picture) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
22	1	150mm Irvine Optical Model Ultrastation 150 Etch Inspection System; Asset # 10110; Olympus BH2-UMA Microscope; Leitz Wetzlar Periplan 10X/18 Optics; Olympus NeoDPlan IC 50X, 20X, 10X, 5X Objectives; (Sample Picture) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
23	1	150mm Irvine Optical Model Ultrastation 150 Etch Inspection System; Asset # 10111; Olympus BH2-UMA Microscope; Olympus WK 10X/20L Optics; Olympus IC 50X, 20X, 10X, 5X Objectives; (Sample Picture) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

24	1	150mm Irvine Optical Ultrastation 3B Model 2 Wet Etch Inspection System; Asset # 10275; (Sample Picture) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
25	1	Lab-Line Model 3850SC Electric Oven; Asset # 10368; Maximum Temperature: 177 Degrees C; Control Type: Digital Setpoint; Overtemperature Protection: Yes; Heat Input: 14.4 kW; 208 Volts; 44 Amps; 3-Phase; 60 Hertz; Excess Temperature Controller; Honeywell Digital Control; Exterior Dimensions: Approx. 72"W x 96"H x 48"D; Double Door; Very Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
26	1	150mm Nanometrics Nanoline 50-2C Model 7201-1267 REV A CD Measurement System; Asset # 10075; Year of Manufacture: 1994; Model 220 Nano Thermal Printer, S/N 15375; Mactronix Model PMR-600 Autoloader, S/N 940216A571; Nanoline Model 9407-0496 Controller, S/N 0694-PC9812 (1994); Olympus Microscope; Olympus WHK 10X/20L Optics; Olympus MSPlan IC 50X, 20X, 5X Objectives; with TMC Technical Vibration Isolation Table; Very Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
27	1	Poly Flow Engineering Model S-417 Triple Tower Tube Cleaner; Asset # 10117; Number of Robots: 4; CVD and Poly Dope; HF/Nitric; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
28	1	Powerware Model 9125-1000 Uninterruptible Power Source; Asset # 10450 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
32	1	Reliability Inc. Model CR1-B Criteria Burn-In Oven; Asset # 10355; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
33	1	Schumacher Model CG100 TEOS Bulk Chemical Delivery System Cabinet; Asset # 10392; P/N 831-4707489; Excellent Condition This item is located at GE - Santa Clara, California
34	1	AMAT Model Endura 5500 Electrical Cabinet / Transformer, S/N 406040, Year 2004 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

36	1	150mm Hitachi Model S-8620 Scanning Electron Microscope, S/N 8607-01, Year 1996; SE Cathode MFG #4-1903; Turbotronik NT10; Turbotronik NT340M; Mitutoyo PSU11-2; Hitachi Load Station with MECS UTC100A Control System, & MECS OF250; Hitachi Power/Electrical Cabinet; HP A4033A Monitor; HP 715/64 CPU; (2) Edwards E2M-12 Vacuum Pumps, S/N's 21536 & 21628 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
37	1	150mm Irvine Optical Ultrastation 3B Model 2 Wet Etch Inspection Station, S/N 8217; Nikon Microscope; (4) Nikon 5X, 10X, 20X, 40X Objectives; No Eyepieces; (Sample Picture) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
38	1	150mm Nanometrics Model 7200-1821 REV B Inspection Station, S/N 1193-H10337, Year 1993; (3) Olympus IC 5X, 10X, 50X Objectives; Model 7200-2236 Rev P1 Film Thickness Unit, S/N 0796-18365, (1996) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
39	1	150mm Jeol Model JSM-6600FXV Scanning Electron Microscope with X-Vision; Year of Manufacture: 1996; GW Type 43 Infrared Chamberscope; Panasonic Video Monitor; Digital Celebris XL590 CPU; Oxford GEM Link Model 6971, S/N 24737-1281-01; Jeol JUS-FEGBB Power System; Seiko Seki STP-300 STP Control Unit This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
40	1	Recif Model VMT8 Wafer Transfer Machine, S/N 127, Year 1998 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
43	1	Semix Model TR-6133UD Spin On Glass Coater; Asset # 24573; Wafer Size Range: 100mm to 200mm; Set Wafer Size: 150mm; Number of Tracks: 3; Number of Cassette Elevators: 2; Number of Photoresist Dispenses: 2; Wafer Edge Bead Removal; Wafer Backside Rinse; Bowl Rinse; Number of Hot Plates: 3; Number of Vapor Prime Hot Plates: 2; Number of Chill Plates: 2; Microprocessor Controller; Water Cooled; 500 Degrees F Max. Temperature; Ran @ 350 Degrees F; 6459.6 Hours Listed; This Tool is Missing a Motor. This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
44	1	150mm DNS Model EEW-622-B WEE Wafer Edge Exposure Unit; Asset # 24545; Year of Manufacture: 1993; Missing One Camera Head But May Not Be Needed Based On Process. No A/C Box But Can Wire Direct. Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

45	1	150mm DNS Model SC-W80A-AVFGLP SOG Furnace; Asset # 24547; Year of Manufacture: 1995; FOR 80A; Power Supply; Chemical Dispensing Units; Only 4,000 Wafers Run; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
46	1	150mm DNS Model 80A Interface; (IFB); Asset # 24576; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
47	1	150mm DNS Model 60A Interface; Asset # 24607; For ASML 5500 & DNS 60A; R to L Load; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
48	1	150mm DNS Model 80B Interface; Asset # 24581; For ASML 5500 & DNS 80B; R to L Load; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
50	1	150mm Nicolet Model ECO8S FTIR; Asset # 24509; Manuals; Software; Computer System; Monitor This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
51	1	150mm Nicolet Model ECO8S FTIR; Asset # 24505; Computer System; Monitor; Cart This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas
52	1	150mm Applied Materials Model 8115 Plasma Etcher; Asset # 24582; Year of Manufacture: 1985; Etcher Type: Barrel; Reactor Center: Cylindrical; Reactor Center Size 30"H x 24" Dia.; Reactor Center Material: Aluminum; Number of Gas Inputs: 3; Rated Power Output: 2000 Watts; Automatching Network: Yes; RF Generator Model: Henry 2000D; Panel Meters: Analog; Water Cooled; Control Cabinet; Heat Exchanger; Manual Loader For 150mm Wafers; 150mm Process Kit; All New Lexan & Flat Pedestals; New Vacuum T/C's; New Henry 2000W RF Generator; New ION Gauge Tube Install; Pneumatic Hoist; New Water Hoses. This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
53	1	150mm Applied Materials Model 8115 Plasma Etcher; Asset # 24584; Original Year of Manufacture: 1985; Etcher Type: Barrel; Reactor Center: Cylindrical; Reactor Center Size 30"H x 24" Dia.; Reactor Center Material: Aluminum; Number of Gas Inputs: 3; Rated Power Output: 2000 Watts; Automatching Network: Yes; RF Generator Model: Henry 2000D; Panel Meters: Analog; Water Cooled; Control Cabinet; Heat Exchanger; Manual Loader For 150mm Wafers; 150mm Process Kit; All New Lexan & Flat Pedestals; New Vacuum T/C's; New Henry 2000W RF Generator; New ION Gauge Tube Install; Pneumatic Hoist; New Water Hoses. This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

55	1	Blue M Model OV-510A-2 Mechanical Convection Horizontal Airflow Electric Oven; Asset # 23993; with Granite Plate; Perforated Stainless Steel Table; Chemical Storage Cabinet; Maximum Temperature: 260 Degrees C; Chamber Size: 15"W x 19"D x 18"H; Control Type: Analog Setpoint; Controller Manufacturer: Power-O-Matic Model 70; Number of Control Zones: 2; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
56	1	200mm/300mm FSM Model 128LC2C Open Cassette/FOUP Automated Film Stress & Wafer Bow Measurement System; Asset # 24041; Year of Manufacture: 1997; Auto Dual Lasers; Automatic Wafer Substrate Thickness Measurements; Missing Skins This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
57	1	FSM Model Laminar II Quantitative Adhesion Tester; Asset # 23995; Missing CPU This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
58	1	200mm/300mm FSM Model 900TC-VAC Integrated Metrology Annealing Chamber; Asset # 23987; Year of Manufacture: 2000; Missing CPU This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
60	1	300mm KLA-Tencor Model SP1 Wafer Loader; Asset # 23996; Year of Manufacture: 1999; Cassette to Cassette: Yes; Single Stage; PRI Robot; CE Marked; New-Never Used This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
61	1	300mm KLA-Tencor Model SP1 Wafer Loader; Asset # 23997; Year of Manufacture: 1998; Cassette to Cassette: Yes; Single Stage; PRI Robot; CE Marked; New-Never Used This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
62	1	200mm LAM Research Model 9400SE Poly Etch System, S/N 4054, Year 1993; TCP 9400 Platform; Cassette to Cassette; Hines 38A Indexer; Envision 1.4.2 Software; PC Controller; SESC Interface; End Point Detection: 520nm & 450nm; RF Generator Model: AE RFG 1250 Halo; (9) Gas Inputs; Process Gases: O2, SF6, HBr, He, Cl2, C2F6, N2, CF4; VAT 65 GV with 2L Turbo This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

63	1	200mm LAM Research Model 4400 Poly Etch System; Asset # 24802; Year of Manufacture: 1999; Hine 38A Indexers; Software Revision Level: Classic; Clamp Chuck; Controller Type: PC Controller; Interface Type: SECS; Cassette to Cassette: Yes; RF Generator Model: AE OEM 650A; Number of Gas Inputs: 3; Process Gases: O2, SF6, He; Thru The Wall Configuration; Machine Hours: 144,642.01; Remote AC Box; Gas Sticks; No Process Kits; Missing AC Rack; Missing Chamber RF Cover; (Complete Audit Available Upon Request) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
64	1	200mm LAM Research Model 4520 Stand-Alone (Rainbow) Oxide Etch System; Asset # 24803; Hines 38A Indexers; Software Revision Level: Envision; Controller Type: PC Controller; Interface Type: Remote SECS; End Point Detection: 053-011094-101; Cassette to Cassette: Yes; ESC Chuck (Flat); Automatch Text: Low Frequency Auto Tuning (LoFAT); Number of Gas Inputs: 5; Process Gases: Ar, CF4, CHF3, O2, N2; RF Generator Model: AE PDW 2200; Gas Sticks Unit 8160 & 1200A MFCs; Thru The Wall Configuration; Machine Hours: 91,293.75; (Complete Audit Available Upon Request) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
65	1	Leitz Ergolux Model 020-448-026 Transmitted Light Microscope; Asset # 24003; Year of Manufacture: 1999; Microscope Type: Upright; Configuration: Brightfield/Darkfield; Illumination Type: Transmitted Light; Binocular Angle: 45 Degrees; Eyepieces: Model NPL Fluotar, Magnification 100X; Focusing: Yes; Objectives: 5X, 10XDF, 10X, 100X; Illumination Power: Volts 110, Watts 30; Illumination Power Transformer: Volts 6, Watts 20; Stage Type: Coaxial X-Y; Camera Type: Polaroid 4x5; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
68	1	Up To 200mm Nanometrics Model 9000i Integrated Film Analysis System; Asset # 23981; Year of Manufacture: 2003; New, Still In Original OEM Packaging; Measures Film Thickness, Optical Constants and Dopant Concentrations; Includes Measurement Unit; Dell OptiPlex GX1 CPU with CD and 3.5" Floppy Drive ; All Cables Included; Can Be Integrated Onto AMAT Producer and Mira Mesa Tools; Kensington Servo Positioning Controller; Excellent Condition; Sample Picture This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

69	1	Up To 200mm Nanometrics Model 9000i Integrated Film Analysis System; Asset # 23979; Year of Manufacture: 2000; New, Still In Original OEM Packaging; Measures Film Thickness, Optical Constants and Dopant Concentrations; Includes Measurement Unit; Dell OptiPlex GX1 CPU with CD and 3.5" Floppy Drive ; All Cables Included; Can Be Integrated Onto AMAT Producer and Mira Mesa Tools; Kensington Servo Positioning Controller; Excellent Condition; Sample Picture This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
70	1	Up To 200mm Nanometrics Model 9000i Integrated Film Analysis System; Asset # 23980; Year of Manufacture: 2003; New, Still In Original OEM Packaging; Measures Film Thickness, Optical Constants and Dopant Concentrations; Includes Measurement Unit; Dell OptiPlex GX1 CPU with CD and 3.5" Floppy Drive ; All Cables Included; Can Be Integrated Onto AMAT Producer and Mira Mesa Tools; Kensington Servo Positioning Controller; Excellent Condition; Sample Picture This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
75	1	200mm Prometrix Model FT750 Patterned Wafer Mapping System; Asset # 23984; Year of Manufacture: 1996; Prometrix FT-700 with FT-750 Upgrade; Cassette to Cassette: Yes; Accomodates Wafer Sizes: 100mm to 200mm; Measures Single & Multi-Layer Films; 410nm to 800nm Reflectivity Range Contour; Die & 3-D Mapping; COGNEX 3100-4MB Vision System Version 1.20A; Olympus MS Plan 2.5X, 5X, 10X, 20X, & 50X Objectives; Auto Focus; 1.5 to 5 Second Measurement Time; Wafer Sorting Capability; Integrated Flat Finder; Vacuum Reservoir; Dual Cassette Elevators; Static Discharge Unit Software; Main Body Monitor; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
76	1	200mm/300mm Rigaku Model Wafer X-300 X-Ray Fluorescence System; Asset # 23988; Year of Manufacture: 1998; Cassette to Cassette: Yes; Controller Type: PC Controller; Wafer Size Range: Maximum Size 300mm, Set Size 200mm; Missing High Voltage Transformer This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

77	1	200mm/300mm Rudolph Model Metapulse-300 Film Thickness Measurement System; Asset # 23994; Year of Manufacture: 2001; Wafer Size Range: Minimum Size 200mm, Maximum Size 300mm, Set Size 300mm; Illumination Source Type: HeNe Laser; Multi-Layer Film Capacity: Yes; Micro Spot Optics: Yes; Scanning Stage: Yes; Wafer Mapping: Yes; In-Situ Capability: Yes; Controller Type: PC Controller; Software Revision Level: Vanguard 6.923P; Water Cooled; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
79	1	200mm SVG Model VTR-7000 LPCVD Vertical Diffusion Furnace; Asset # 24013; Year of Manufacture: 1995; Process Capabilities: Arsenic Doped TEOS; Number of Cassette Platforms: 4; Controller Manufacturer/Model: MKS 652; Number of Control Zones: 3; Overtemperature Protection: Yes; Cassette to Cassette: Yes; 3-Zone Heating Element; Maximum Load Size: 160 Wafer; Two Boat/Single Tube System; Anti-Static System; Heat Deflector Option; Pressure Control to 2 Torr; Schumacher Bubbler with 1483 Controller; Thermco/Watlow 8 Zone Heater Jacket Controller This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
80	1	200mm SVG Model VTR-7000 LPCVD Vertical Diffusion Furnace; Asset # 24016; Year of Manufacture: 1995; Process Capabilities: LPCVD Anneal; Number of Cassette Platforms: 4; Controller Manufacturer/Model: MKS 652; Number of ControlZones: 3; Overtemperature Protection: Yes; Cassette to Cassette: Yes; Maximum Load Size: 160 Wafer; Two Boat/Single Tube System; Anti-Static System; Heat Deflector Option; 3-Zone Heating Element; Pressure Control to 2 Torr; Single Disk Floppy Recipe System This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
81	1	200mm TEL Model Alpha 8-SE LPCVD Vertical Diffusion Furnace; Asset # 24047; Year of Manufacture: 1999; Process Capabilities: LPCVD SiN (FTP SiN/AsH3 Anneal); Number of Cassette Platforms: 2; UP Box; In-Situ Clean; Controller Type: WAVES System Controller; Maximum Temperature 700 Degrees C; Process Gases: Sin, AsH3; Very Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

82	1	Semix Model TR-6133UD Spin On Glass Coater; Asset # 20503; Wafer Size Range: 100mm to 200mm; Set Wafer Size: 150mm; Number of Tracks: 3; Number of Cassette Elevators: 2; Number of Photoresist Dispenses: 2; Wafer Edge Bead Removal; Wafer Backside Rinse; Bowl Rinse; Number of Hot Plates: 3; Number of Vapor Prime Hot Plates: 2; Number of Chill Plates: 2; Microprocessor Controller; Water Cooled; 500 Degrees F Max. Temperature; Ran @ 350 Degrees F; 4788.4 Hours Listed; W/ Manuals; Missing Canisters & Cup Assembly This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
83	1	150mm LAM Research Model 490 Nitride Etch System; Asset # 20513; Year of Manufacture: 1985; Wafer Size Range: Set Size 150 mm; Process: Nitride Poly; Controller Type: Microprocessor Controller; Software Revision Level: AA-2; Interface Type: SECS; End Point Detection: 2 Channel LAM Internal; Cassette to Cassette: Yes; Automatch Text: LAM 490 Match; Number of Gas Inputs: 6; Process Gases: Has used ClF3, O2, He, Cl2, SF6; Good Condition; (Complete Audit Available Upon Request) This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
84	1	150mm Branson/IPC Model L3100 Low Particle Barrel Asher; Asset # 20554; (2) Gas Inputs; Chamber Size: 20" Deep x 12" Dia.; Automatching Network; Water Cooled; Branson/IPC Model 3000LP Control Unit, P/N 12055-D, S/N 10003376; ENI Model OEM-12-11491 Solid State Power Generator, S/N 1927 (1992); Branson/IPC Power Distribution LP, P/N 12255-G, S/N 10003604; Installed In Rack; W/ Manual This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
85	1	SVG / Thermco Series 8000 AVP-16 Advanced Vertical Processor LPCVD System, S/N 4129; S.O # A20323; CE Marked; Wafer Size Range: 200mm Maximum; Wafer Set Size: 150mm; Process Capabilities: Nitride/LPCVD; Number of Cassette Platforms: 16; Robot Manufacturer: Genmark Model 2LE0997086; Controller: Sun Workstation; Software Revision Level 2.4.1; Interface: SECS 2; Number of Control Zones: 5; Overtemperature Protection: Yes; Process Gases: Dichlorosilane / Ammonia; Carousel Loader Capable of Back to Back Loads; Omega Over-Temperature Controller; SVG/Thermco Self-Contained Power System; Maintenance/Installation Manuals; Electric Lift; Year of Manufacture: 1997; Excellent Condition This item is located at 13920 Senlac Drive #200, Farmers Branch, Texas 75234

86	1	150mm Mactronix Model AWI-600 Automatic Wafer Sorter; Asset # 20607; AWS Main Base; Set Up For: FA 196-60MLB; H.R.C Tech Light Cube; Remote Touch Pad Control with Joystick; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
88	1	ATM Model AT-3000 PICC Lead Conditioner; Asset # 20843 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
89	1	150mm Hitachi Model S-6000 Scanning Electron Microscope; Asset # 20870; Cassette to Cassette: Yes; Tilting Stage: Yes; with Control Cabinet & Power Supply Cabinet; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
90	1	KLA Model 5011 Overlay Precision Measurement System; S/N 288; 2-Cassette; W/ Driel Model 66003 Laser, S/N 324 (1993); COHU Model 6312-2000/0000 Solid State Camera; Sony Trinitron Color Video Monitor; Hewlett-Packard Computer Monitor; Falco Computer Monitor; Digital Expansion Storage Unit; Digital VAXstation 4000-VLC Processor This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
91	1	150mm Hitachi Model IS-3270 Patterned Wafer Inspection System; Year of Manufacture: 1994; Software: Version-01 This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
92	1	150mm Kokusai Model Vertron II DD-802V Vertical Diffusion Furnace; Year of Manufacture: 1994; with Manuals; Teach Pendants; Back-Up Software; 150 Wafer Max Load; Process Capabilities: Oxidation; Number of Cassette Platforms: 1; Robot Manufacturer: Kokusait; Number of Control Zones: 4; Over-Temperature Protection: Yes; Process Gases: N2 & H2; Interface Type: SECS 2; Water Cooled; Like New Condition; (Complete Audit Available Upon Request) This item is located at 13920 Senlac Drive #200, Farmers Branch, Texas 75234
93	1	150mm Kokusai Model Vertron V(E) DJ-825V Vertical Diffusion Furnace; Year of Manufacture: 1996; with Manuals; Extra Memory Cards; Teach Pendants; Back-Up Software; 150 Wafer Max Load; Process Capabilities: Doped Poly; Number of Cassette Platforms: 2; Robot Manufacturer: Kokusai; Number of Control Zones: 4; Over-Temperature Protection: Yes; Process Gases: Silane & PH3; Interface Type: SECS 2; Water Cooled; Like New Condition; (Complete Audit Available Upon Request) This item is located at 13920 Senlac Drive #200, Farmers Branch, Texas 75234

94	1	Delta Design Model 2300 Environmental Chamber; Asset # 10350; Bench Top; Type V Controller; Test Volume: 0.37 cubic feet (10.5 liters); Internal Dimensions: 8"H x 10"W x 8"D (20.32 x 25.40 x 20.32 cm); Overall Dimensions: 12 ¾"H x 17 ½"W x 20 ¾"D (32.38 x 44.45 x 52.70 cm); Temperature Range: -73°C to + 315°C or -100°F to + 600°F; OPTION: -184°C (-300°F) With optional LN2; Heat-Up Rate: 24°C / Minute; Cool-Down Rate: 31° C / Minute; LCO2 Consumption: 5.6 lbs/hr at -53°C (-65°F); Air Circulation: Vertical Air Flow Pattern; Net Wt.: (Approx.) 47 lbs (21.3 Kg); Shipping Wt.: (Approx.) 60 lbs (27.2 Kg); Door Options: Available Blank with Tray; Ten 3/8" Dia Ports with Tray; Window and Five 3/8" Dia Ports - No Tray; Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
95	1	150mm Leo Model S435VP Scanning Electron Microscope; Asset # 10102; 5-Axis Joystick Controller; Mitsubishi P78U Video Copy Processor, (1995); Edwards AGD mbar/torr Meter; Computer Desk Base with Floppy Drives; Dell Monitor; Very Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
98	1	150mm DNS Model SC-W60A-AV Coater; Asset # 24558; Year of Manufacture: 1995; Photoresist Type: Positive; Number of Tracks: 1; Number of Cassette Elevators: 2; Number of Photoresist Dispenses: 4; Wafer Edge Bead Removal: Yes; Wafer Backside Rinse: Yes; Bowl Rinse: Yes; Number of Vapor Prime Hot Plates: 2; Number of Hot Plates: 4; Number of Chill Plates: 2; Controller Type: PC Controller; External Cooling: Forced Air Cooled; (8) Iwaki Pumps; Chemical Delivery Cabinet (HMDS Auto Supply) with (2) Komatsu KCE-53WS-A Temperature Control Pumps and (2) Komatsu FR-531-B Controllers; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
99	1	150mm DNS Model SD-W60A-AVP Developer; Asset # 24561; Year of Manufacture: 1996; Number of Hot Plates: 4; Number of Chill Plates: 2; Controller Type: PC Controller; Pressure Dispense Delivery System; Chemical Delivery Cabinet with (2) Komatsu KCE-53WS-A Temperature Control Pumps and (2) Komatsu FR-531-B Controllers (Shares Between Coat & Develop); Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

100	1	150mm DNS Model SC-W60A-AVP Developer; Asset # 24566; Year of Manufacture: 1994; Number of Hot Plates: 4; Number of Chill Plates: 2; Controller Type: PC Controller; Pressure Dispense Delivery System; Chemical Delivery Cabinet with (2) Komatsu KCE-53WS-A Temperature Control Pumps and (2) Komatsu FR-531-B Controllers; On-Board Edge Exposure Unit; Very Good Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
101	1	Up To 300mm CDE ResMap Model 463-FOUP Resistivity Mapper/Dual or Four-Point Probe; Asset # 23991; Year of Manufacture: 2001; Wafer Size Range: Minimum Size 150mm, Maximum Size 300mm, Set Size 300mm; FOUP Loader: Yes; Wafer Handling: Standard Robot; Auto Load; Resistivity Testing: Yes; Sheet Resistance Testing: Yes; Thickness Testing: Yes; Wafer Mapping: Yes; Controller Type: PC Controller; Interface Type: SECS 2; Only 1 of 4 Probe Heads Installed; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
102	1	Up To 300mm CDE ResMap Model 463-FOUP Resistivity Mapper/Dual or Four-Point Probe; Asset # 23991; Year of Manufacture: 2001; Wafer Size Range: Minimum Size 150mm, Maximum Size 300mm, Set Size 300mm; FOUP Loader: Yes; Wafer Handling: Standard Robot; Auto Load; Resistivity Testing: Yes; Sheet Resistance Testing: Yes; Thickness Testing: Yes; Wafer Mapping: Yes; Controller Type: PC Controller; Interface Type: SECS 2; Only 1 of 4 Probe Heads Installed; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
107	1	Up To 300mm Nanometrics Model 8300XSE Film Thickness Analyzer with Spectroscopic Ellipsometry; Asset # 23985; Year of Manufacture: 1999; Wafer Size Range: Minimum Size 200mm, Maximum Size 300mm, Set Size 300mm; Illumination Source Type: HeNe Laser; Multi-Layer Film Capacity: Yes; Micro Spot Optics: Yes; Scanning Stage: Yes; Wafer Mapping: Yes; In-Situ Capability: Yes; Objectives: 4X, 10X, 15X, 40X; Controller Type: PC Controller; Two Stages; CCD Laser Pre-Aligner Ellipsometer; Kensington Robot; Smart Box Head Control; Linear Turret; Software Revision Level: OS2 1.41.1; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

108	1	Up To 300mm Nanometrics Model 8300XSE Film Thickness Analyzer with Spectroscopic Ellipsometry; Asset # 23986; Year of Manufacture: 1999; Wafer Size Range: Minimum Size 200mm, Maximum Size 300mm, Set Size 300mm; Illumination Source Type: HeNe Laser; Multi-Layer Film Capacity: Yes; Micro Spot Optics: Yes; Scanning Stage: Yes; Wafer Mapping: Yes; In-Situ Capability: Yes; Objectives: 4X, 10X, 15X, 40X; Controller Type: PC Controller; Two Stages; CCD Laser Pre-Aligner Ellipsometer; Kensington Robot; Smart Box Head Control; Linear Turret; Software Revision Level: OS2 1.41.1; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
109	1	200mm/300mm SDI Model FAaST 330-DP+USVP+SILC Surface Photo Voltage Test System, S/N 01-100283, Year 2001; SILC-EPI-T-COCOS; SPV With Corona; SPV-Cu Option FWA; RMT RESP SASS Time PDM; MC; Enhanced Mode Soft BDF; CSC (Vsb, Qsc); COCOS (Vfb, Qtot, Dit, Nit, Cox/Tox); Near Surface Doping SILC II; SASS (Including Wafer Mapping) Data Review Software Version V.8.15.13; Line Conditioner; Brooks Automation FIXLOAD 300mm Load Port For FOUPs; FOUPs Load Port; Mini Environment This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
112	1	200mm Hitachi Model S-4500 Scanning Electron Microscope; Asset # 24066; Year of Manufacture: 1994; Resolution: 6:00 A; Cassette to Cassette: Yes; Tilting Stage: Yes; Gun Type: Field Emission; Controller Type: PC Controller; Software Revision Level: V.5 With Digital Image Capturing System; Manual Stage; Quartz PCL; Type 1 Chamber; Diffusion Pumps; Mechanical Vacuum Pump Included; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
113	1	100mm Hitachi Model S-4700 Field Emission/Scanning Electron Microscope; Asset # 23969; Year of Manufacture: 1998; Resolution: 12.00 A; Magnification: 500kX; Acceleration Voltage: 0 to 30 kV, Number Of Steps: 100; CD Measurement Range: 1.50 to 2.50 um; CD Measurement Resolution: 25 A; Cassette to Cassette: Yes; Tilting Stage: Yes; Gun Type: Field Emission; Controller Type: PC Controller; Software Revision Level: 2.9.5; Software: Operating Part v.2.1; Control Part v.3.3; Software Options: Full Panel, Photo, CD Measurement; Type 1; Motorized Stage; XEI Scientific SEM Clean N2 Purge System; Robinson Chamber View; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744

115	1	200mm KLA-Tencor Model 6200 Wafer Surface Inspection System; Asset # 23935; Year of Manufacture: 1992; Cassette to Cassette: Yes; Configurable for Multiple Wafers Sizes Up to 200mm; Dual Stage Cassette Loader; Software Revision Level: 4.15.1; Excellent Condition; Sample Pictures This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
116	1	200mm KLA-Tencor Model 6200 Wafer Surface Inspection System; Asset # 23936; Year of Manufacture: 1995; Cassette to Cassette: Yes; Configurable for Multiple Wafers Sizes Up to 200mm; Dual Stage Cassette Loader; Software Revision Level: 4.15.1; Excellent Condition; Sample Pictures This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
119	1	200mm KLA-Tencor Model SP-1 Classic Unpatterned Wafer Surface Analysis System; Asset # 24010; Year of Manufacture: 2002; Software Revision Level: 3.30.1829; Argon Ion Laser (488nm); Measurement Chamber With ULPA Filter & Blower Unit; Operator Interface: MS Windows NT 4.0; Interactive Pointing Device; Flat Panel Display; Defect Map & Histogram With Zoom Microview Measurement Capability; Provides Sensitivity, Repeatability, Surface Quality Measurements & Throughput Capabilities Required For 0.18um Process Technologies & Beyond; 0.08um Defect Sensitivity On Well-Polished Silicon; 95% Capture; Brooks Automation FIXLOAD 300mm Load Port for FOUPs; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744
120	1	150mm LAM Research Model TCP 9600SE Stand-Alone Rainbow Metal Etch System; Asset # 23928; Year of Manufacture: 1995; TCP 9600 Platform; Hines 38A Indexer; Cassette to Cassette: Yes; End Point Detection: 853-001983-011; RF Generator Model: AE RFG1250 Halo; Number of Gas Inputs: 6; Process Gases: CL2, BCL3, N2, CH4, CF4, O2; DSQ; ESC; Interface Type: SECS; Controller Type: PC Controller; Software Revision Level: Envision 1.5.1; Excellent Condition This item is located at 4129 Commercial Center Dr, Suite 475 Austin, Texas 78744